



Attorney's Docket No.: 10559-584002
Intel Ref.: P12765C

AF/IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Chris E. Barns et al. Art Unit : 1765
Serial No. : 10/799,996 Examiner : Lan Vinh
Filed : March 12, 2004
Title : POLYSILICON OPENING POLISH

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF APRIL 17, 2006

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

August 17, 2006

Date of Deposit

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Typed or Printed Name of Person Signing Certificate